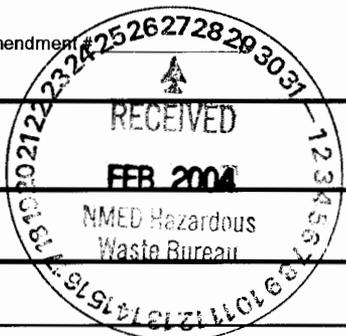


PSC 2/20/04

<p><b>MAIL THE COMPLETED FORM TO:</b> The Appropriate EPA Regional or State Office</p>	<p>United States Environmental Protection Agency <b>RCRA SUBTITLE C SITE IDENTIFICATION FORM</b></p>		
<p><b>1. Reason for Submittal and Status of Information Supplied (see instructions on pages 10 and 11)</b>  CHECK CORRECT BOX(ES)</p>	<p><b>A. Reason for Submittal:</b></p> <p><input type="checkbox"/> To provide initial notification (to obtain an EPA ID Number for hazardous waste, universal waste, or used oil activities).</p> <p><input type="checkbox"/> To provide subsequent notification (to update site identification information).</p> <p><input type="checkbox"/> As a component of a First RCRA Hazardous Waste Part A Permit Application.</p> <p><input type="checkbox"/> As a component of a Revised RCRA Hazardous Waste Part A Permit Application (Amendment).</p> <p><input checked="" type="checkbox"/> As a component of the Hazardous Waste Report.</p>		
<p><b>2. Site EPA ID Number (see instructions on page 11)</b></p>	<p>EPA ID Number: NMD000709782</p>		
<p><b>3. Site Name (see instructions on page 11)</b></p>	<p>Legal Name: PHILIPS SEMICONDUCTORS</p>		
<p><b>4. Site Location Information (see instructions on page 11)</b></p>	<p>Street Address: 9201 PAN AMERICAN FRWY. NE</p>		<p>State: NM</p>
	<p>City, Town, or Village: ALBUQUERQUE</p>	<p>Zip Code: 87113- -</p>	
	<p>County Name: BERNALILLO</p>	<p>Zip Code: 87113- -</p>	
<p><b>5. Site Land Type (see instructions on page 11)</b></p>	<p>Site Land Type: <input checked="" type="checkbox"/> Private <input type="checkbox"/> County <input type="checkbox"/> District <input type="checkbox"/> Federal <input type="checkbox"/> Indian <input type="checkbox"/> Municipal <input type="checkbox"/> State <input type="checkbox"/> Other</p>		
<p><b>6. North American Industry Classification System (NAICS) Code(s) for the Site (see instructions on page 11)</b></p>	<p>A. 334413</p>	<p>B.</p>	
	<p>C.</p>	<p>D.</p>	
<p><b>7. Site Mailing Address (see instructions on page 12)</b></p>	<p>Street or P.O. Box: 1109 MCKAY DR SJ-55</p>		
	<p>City, Town, or Village: SAN JOSE</p>		<p>State: NM</p>
	<p>Country:</p>	<p>Zip Code: 95131-1706-</p>	
<p><b>8. Site Contact Person (see instructions on page 12)</b></p>	<p>First Name: GLEN</p>	<p>MI:</p>	<p>Last Name: TSUKAMOTO</p>
	<p>Phone Number: (408) 474-6129 Extension:</p>		<p>Email: GLEN.TSUKAMOTO@PHILIPS.COM</p>
<p><b>9. Legal Owner and Operator of the Site (see instructions on pages 12 and 13)</b></p>	<p><b>A. Name of Site's Operator:</b> PHILIPS SEMICONDUCTORS</p>		<p><b>Date Became Operator (mm/dd/yyyy):</b> 01/01/1980</p>
	<p><b>Operator Type:</b> <input checked="" type="checkbox"/> Private <input type="checkbox"/> County <input type="checkbox"/> District <input type="checkbox"/> Federal <input type="checkbox"/> Indian <input type="checkbox"/> Municipal <input type="checkbox"/> State <input type="checkbox"/> Other</p>		
	<p><b>B. Name of Site's Legal Owner:</b> PHILIPS ELECTRONICS NORTH AMERICA</p>		<p><b>Date Became Owner (mm/dd/yyyy):</b> 01/01/1980</p>
	<p><b>Owner Type:</b> <input checked="" type="checkbox"/> Private <input type="checkbox"/> County <input type="checkbox"/> District <input type="checkbox"/> Federal <input type="checkbox"/> Indian <input type="checkbox"/> Municipal <input type="checkbox"/> State <input type="checkbox"/> Other</p>		
	<p>Street or P.O. Box: 1251 AVENUE OF THE AMERICAS</p>		
	<p>City, Town, or Village: NEW YORK</p>		
<p>State: NY Zip Code: 10020-104 - Country:</p>			

**10. Type of Regulated Waste Activity (Mark 'X' in the appropriate boxes. See instructions on pages 13, 14, 15, and 16)**

**A. Hazardous Waste Activities**

**1. Generator of Hazardous Waste (choose only one of the following three categories)**

- a. LQG: Greater than 1,000 kg/mo (2,200 lbs.) of non-acute hazardous waste; or
- b. SQG: 100 to 1,000 kg/mo (220 - 2,200 lbs.) of non-acute hazardous waste; or
- c. CESQG: Less than 100 kg/mo of non-acute hazardous waste

In addition, indicate other generator activities (check all that apply)

- d. United States Importer of Hazardous Waste
- e. Mixed Waste (hazardous and radioactive) Generator

For Items 2 through 6, check all that apply:

- 2. Transporter of Hazardous Waste
- 3. Treater, Storer, or Disposer of Hazardous Waste (at your site) Note: A hazardous waste permit is required for this activity
- 4. Recycler of Hazardous Waste (at your site) Note: A hazardous waste permit may be required for this activity.
- 5. Exempt Boiler and/or Industrial Furnace**
  - a. Small Quantity On-site Burner Exemption
  - b. Smelting, Melting, Refining Furnace Exemption
- 6. Underground Injection Control

**B. Universal Waste Activities**

1. Large Quantity Handler of Universal Waste (accumulate 5,000 KG or more) [refer to your State regulations to determine what is regulated]. Indicate types of universal waste generated and/or accumulated at your site. (check all boxes that apply)

	Generated	Accumulated
a. Batteries	<input type="checkbox"/>	<input type="checkbox"/>
b. Pesticides	<input type="checkbox"/>	<input type="checkbox"/>
c. Thermostats	<input type="checkbox"/>	<input type="checkbox"/>
d. Lamps	<input type="checkbox"/>	<input type="checkbox"/>
e. Other _____	<input type="checkbox"/>	<input type="checkbox"/>
f. Other _____	<input type="checkbox"/>	<input type="checkbox"/>
g. Other _____	<input type="checkbox"/>	<input type="checkbox"/>

**2. Destination Facility for Universal Waste**  N

Note: A hazardous waste permit may be required for this activity.

**C. Used Oil Activities**

**1. Used Oil Transporter - Indicate Type(s) of Activity(ies)**

- a. Transporter
- b. Transfer Facility

**2. Used Oil Processor and/or Re-refiner - Indicate Type(s) of Activity(ies)**

- a. Processor
- b. Re-refiner

3. Off-Specification Used Oil Burner

**4. Used Oil Fuel Marketer - Indicate Type(s) of Activity(ies)**

- a. Marketer Who Directs Shipment of Off-Specification Used Oil to Off-Specification Used Oil Burner
- b. Marketer Who First Claims the Used Oil Meets the Specifications

**11. Description of Hazardous Wastes (see instructions on page 16)**

**A. Waste Codes for Federally Regulated Hazardous Wastes.** Please list the waste codes of the Federal hazardous wastes handled at your site. List them in the order they are presented in the regulations (e.g., D001, D003, F007, U112). Use an additional page if more spaces are needed.

F003	D003	D001	D004	D009	D002	D007
D008						





U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

**FORM GM**

**WASTE GENERATION AND MANAGEMENT**

Sec. 1	<b>A. Waste Description</b> IGNITABLE SPENT SOLVENT FROM THE MANUFACTURE OF SEMICONDUCTOR DEVICES. SOLVENT USED FOR STRIPPING PROPERTIES; MIXTURE OF MANY DIFFERENT ORGANIC SOLVENTS INCLUDING N-METHYL PYRROLIDONE, 2,2-AMINOETHOXYETHANOL, AND ACETONE.		
	<b>B. EPA Hazardous Waste Code</b> D001 F003		<b>C. State Hazardous Waste Code</b>
<b>D. Source Code</b> G02 Management Method code for Source code G25		<b>E. Form Code</b> W203	<b>F. Quantity Generated in 2003</b> 75.75
			<b>G. UOM</b> Density 2 1.00 spec.gra

Sec. 2	<b>Was any of this waste managed on-site?</b> No	
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b> <b>Quantity treated, disposed, or recycled on-site in 2003</b>

Sec. 3	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b>	<b>B. EPA ID No. of facility to which waste was shipped</b>	<b>C. Off-site Management Method code shipped to</b>	<b>D. Total quantity shipped in 2003</b>
1	KSD980633259	H050	29.74
2	NMD002208627	H141	46.01

**Comments**  
NULL.



**SITE NAME**  
 PHILIPS SEMICONDUCTORS  
 9201 PAN AMERICAN FRWY. NE  
 ALBUQUERQUE, NM 87113  
 EPA ID NO: NMD000709782



**WASTE GENERATION AND MANAGEMENT**

Sec. 1	<b>A. Waste Description</b>		
	IGNITABLE SPENT SOLVENT FROM THE MANUFACTURE OF SEMICONDUCTOR DEVICES. MATERIAL IS USED AS A SURFACE COATING FOR PRODUCT (RESIST/SOG WASTE). MIXTURE INCLUDES PROPYLENE GLYCOL MONOMETHYL ETHER ACETATE, ACETONE, AND ISOPROPYL ALCOHOL.		
<b>B. EPA Hazardous Waste Code</b>		<b>C. State Hazardous Waste Code</b>	
D001 F003			
<b>D. Source Code</b>	<b>E. Form Code</b>	<b>F. Quantity Generated in 2003</b>	<b>G. UOM</b>
G06 Management Method code for Source code G25	W203	12.91	Density 2 1.00

spec. gra

Sec. 2	<b>Was any of this waste managed on-site?</b>	
	No	
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b> <b>Quantity treated, disposed, or recycled on-site in 2003</b>

Sec. 3	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b>		
	Yes		
<b>Site #</b>	<b>B. EPA ID No. of facility to which waste was shipped</b>	<b>C. Off-site Management Method code shipped to</b>	<b>D. Total quantity shipped in 2003</b>
1	IND093219012	H061	1.38
2	AZD081705402	H061	3.31
3	NMD002208627	H141	8.21

**Comments** SEC. 1, BOX D - WAFER COATING WITH PHOTSENSITIVE CHEMICAL (PHOTORESIST) AS PART OF PHOTO PROCESS IN THE MANUFACTURING OF SEMICONDUCTOR DEVICES. MIXED WITH THIS WASTE IS SPIN-ON-GLASS, ANOTHER WAFER COATING MATERIAL WHICH IS COMPATIBLE WITH

NULL.



**SITE NAME**  
 PHILIPS SEMICONDUCTORS  
 9201 PAN AMERICAN FRWY. NE  
 ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782



**WASTE GENERATION AND MANAGEMENT**

<b>Sec. 1</b>	<b>A. Waste Description</b> SOLVENT CONTAMINATED WIPES AND MATERIALS FROM CLEANING OPERATIONS; CONTAINS PRIMARILY ACETONE AND ISOPROPYL ALCOHOL.		
<b>B. EPA Hazardous Waste Code</b> F003		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G09 Management Method code for Source code G25	<b>E. Form Code</b> W002	<b>F. Quantity Generated in 2003</b> 5.46	<b>G. UOM</b> 2 Density 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> No	
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b> <b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b>	<b>B. EPA ID No. of facility to which waste was shipped</b>	<b>C. Off-site Management Method code shipped to</b>	<b>D. Total quantity shipped in 2003</b>
1	AZD081705402	H141	0.99
2	IND093219012	H141	0.74
3	NMD002208627	H141	3.72

**Comments** SEC. 1, BOX D - RAGS AND PPE CONTAMINATED WITH NONHALOGENATED SOLVENTS (ACETONE/ISOPROPYL ALCOHOL) USED FOR WIPING DOWN EQUIPMENT AND WORK STATIONS AND SOME SPILL CLEAN-UP.  
 .NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**WASTE GENERATION AND MANAGEMENT**

**FORM GM**

**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

<b>Sec. 1</b>	<b>A. Waste Description</b> ARSENIC CONTAMINATED MATERIALS (SOLID) FROM EQUIPMENT AND PARTS CLEANING IN ION IMPLANT.		
<b>B. EPA Hazardous Waste Code</b> D004		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G13 Management Method code for Source code G25	<b>E. Form Code</b> W002	<b>F. Quantity Generated in 2003</b> 3.99	<b>G. UOM</b> 2 Density 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> No		
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>	
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b>	<b>B. EPA ID No. of facility to which waste was shipped</b>	<b>C. Off-site Management Method code shipped to</b>	<b>D. Total quantity shipped in 2003</b>
1	AZD081705402	H141	1.46
2	IND093219012	H141	0.45
3	NMD002208627	H141	2.06

**Comments**  
  
NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**WASTE GENERATION AND MANAGEMENT**

**FORM GM**

**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

<b>Sec. 1</b>	<b>A. Waste Description</b> MERCURY CONTAINING MATERIALS/ITEMS. MERCURY CONTAINING LAMPS USED IN PHOTO PROCESS.		
<b>B. EPA Hazardous Waste Code</b> D009		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G19 <b>Management Method code for Source code G25</b>	<b>E. Form Code</b> W320	<b>F. Quantity Generated in 2003</b> 0.25	<b>G. UOM</b> 2 <b>Density</b> 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> No		
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>	
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b> 1	<b>B. EPA ID No. of facility to which waste was shipped</b> NMD002208627	<b>C. Off-site Management Method code shipped to</b> H141	<b>D. Total quantity shipped in 2003</b> 0.25

**Comments** SEC. 1, BOX D - LAMP REPLACEMENT FROM PHOTO PROCESS AND FLUORESCENT FIXTURES. MERCURY CONTAINED IN MANUFACTURED ARTICLES.  
  
NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**WASTE GENERATION AND MANAGEMENT**

**FORM GM**

**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

<b>Sec. 1</b>	<b>A. Waste Description</b> ADHESION PROMOTER IN THE MANUFACTURE OF SEMICONDUCTOR DEVICES. SOLE INGREDIENT IS HEXAMETHYLDISILAZANE.		
<b>B. EPA Hazardous Waste Code</b> D001 D003		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G06 <b>Management Method code for Source code G25</b>	<b>E. Form Code</b> W210	<b>F. Quantity Generated in 2003</b> 0.04	<b>G. UOM 2</b> Density 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> No	
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b> <b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b>	<b>B. EPA ID No. of facility to which waste was shipped</b>	<b>C. Off-site Management Method code shipped to</b>	<b>D. Total quantity shipped in 2003</b>
1	AZD081705402	H141	0.01
2	IND093219012	H141	0.00
3	NMD002208627	H141	0.02

**Comments** HEXAMETHYLDISILAZANE IS A IGNITABLE, WATER REACTIVE SOLVENT.  
  
NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
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**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782



**WASTE GENERATION AND MANAGEMENT**

<b>Sec. 1</b>	<b>A. Waste Description</b> FLOWABLE OXIDE (FOX), AN IGNITABLE SPENT SOLVENT, USED IN THE MANUFACTURE OF SEMICONDUCTOR DEVICES AND PRIMARILY CONTAINS ORGANIC SILOXANE SOLVENTS.		
<b>B. EPA Hazardous Waste Code</b> D001 D003		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G06 <b>Management Method code for Source code G25</b>	<b>E. Form Code</b> W210	<b>F. Quantity Generated in 2003</b> 1.17	<b>G. UOM 2</b> Density 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> No	
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b> <b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b>	<b>B. EPA ID No. of facility to which waste was shipped</b>	<b>C. Off-site Management Method code shipped to</b>	<b>D. Total quantity shipped in 2003</b>
1	AZD081705402	H141	0.51
2	IND093219012	H141	0.61
3	NMD002208627	H141	0.58

**Comments** THIS MATERIAL IS IGNITABLE AND WATER REACTIVE  
  
NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**WASTE GENERATION AND MANAGEMENT**

**FORM GM**

SITE NAME  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
EPA ID NO: NMD000709782

Sec. 1	<b>A. Waste Description</b> LAB PACK OF USED OR EXPIRED LAB/PRODUCTION CHEMICALS AND STANDARDS.		
<b>B. EPA Hazardous Waste Code</b> D002 D001 D003		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G22 Management Method code for Source code G25	<b>E. Form Code</b> W001	<b>F. Quantity Generated in 2003</b> 0.58	<b>G. UOM 2</b> Density 0.00 spec.gra

Sec. 2	<b>Was any of this waste managed on-site?</b> No	
<b>ON-SITE PROCESS SYSTEM 1</b> On-site process system type		<b>ON-SITE PROCESS SYSTEM 2</b> On-site process system type
Quantity treated, disposed, or recycled on-site in 2003		Quantity treated, disposed, or recycled on-site in 2003

Sec. 3	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b> 1	<b>B. EPA ID No. of facility to which waste was shipped</b> AZD081705402	<b>C. Off-site Management Method code shipped to</b> H141	<b>D. Total quantity shipped in 2003</b> 0.58

**Comments**  
NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

**FORM GM**

**WASTE GENERATION AND MANAGEMENT**

<b>Sec. 1</b>	<b>A. Waste Description</b>	IGNITABLE SOLVENTS FOR USE IN THE SEMICONDUCTOR MANUFACTURING PROCESS. SOLVENT USED FOR STRIPPING PROPERTIES; MIXTURES OF MANY DIFFERENT ORGANIC SOLVENTS INCLUDING N-METHY PRROLIDONE, 2,2-AMINOTHIOXYETHANOL, AND ACETONE		
	<b>B. EPA Hazardous Waste Code</b>	<b>C. State Hazardous Waste Code</b>		
	D001 F003			
<b>D. Source Code</b>	<b>E. Form Code</b>	<b>F. Quantity Generated in 2003</b>	<b>G. UOM</b>	
G15 Management Method code for Source code G25	W203	14.99	Density 2 1.00 spec.gra	

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b>			
	No			
	<b>ON-SITE PROCESS SYSTEM 1</b>	<b>ON-SITE PROCESS SYSTEM 2</b>		
	<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b>		
	Yes		
<b>Site #</b>	<b>B. EPA ID No. of facility to which waste was shipped</b>	<b>C. Off-site Management Method code shipped to</b>	<b>D. Total quantity shipped in 2003</b>
1	NMD002208627	H141	14.99

<b>Comments</b>	SOLVENTS DISPOSED AS PART OF DECOMMISSIONING THE PLANT. THE MANUFACTURING PROCESS STOPPED IN OCTOBER OF 2003.
<b>NULL.</b>	



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
EPA ID NO: **NMD000709782**



**WASTE GENERATION AND MANAGEMENT**

<b>Sec. 1</b>	<b>A. Waste Description</b>	IGNITABLE SOLVENT USED IN THE MANUFACTURE OF SEMICONDUCTOR DEVICES. MATERIAL IS USED FOR THE SURFACE COATING FOR PRODUCTION PURPOSES. MIXTURE INCLUDES PROPYLENE GLYCOL MONOMETHYL ETHER ACETATE, ACETONE, AND ISOPROPYL ALCOHOL.		
	<b>B. EPA Hazardous Waste Code</b>	<b>C. State Hazardous Waste Code</b>		
	F003 D001			
<b>D. Source Code</b>	<b>E. Form Code</b>	<b>F. Quantity Generated in 2003</b>	<b>G. UOM</b>	
G15 Management Method code for Source code G25	W203	0.75	Density 2 1.00 spec.gra	

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b>			
	No			
	<b>ON-SITE PROCESS SYSTEM 1</b>	<b>ON-SITE PROCESS SYSTEM 2</b>		
	<b>On-site process system type</b>	<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b>		
	Yes		
<b>Site #</b>	<b>B. EPA ID No. of facility to which waste was shipped</b>	<b>C. Off-site Management Method code shipped to</b>	<b>D. Total quantity shipped in 2003</b>
1	NMD002208627	H141	0.75

<b>Comments</b>	CHEMICALS DISPOSED AS PART OF THE DECOMMISSIONING OF THE PLANT. THE MANUFACTURING PROCESS STOPPED IN OCTOBER OF 2003.
<b>NULL.</b>	



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**WASTE GENERATION AND MANAGEMENT**

**FORM GM**

SITE NAME  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
EPA ID NO: NMD000709782

Sec. 1	<b>A. Waste Description</b> ADHESION PROMOTER USED IN THE MANUFACTURE OF SEMICONDUCTOR DEVICES. SOLE INGREDIENT IS HEXAMETHYLDISILAZANE.		
<b>B. EPA Hazardous Waste Code</b> D001 D003		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G15 Management Method code for Source code G25	<b>E. Form Code</b> W210	<b>F. Quantity Generated in 2003</b> 0.05	<b>G. UOM</b> 2 Density 1.00 spec.gra

Sec. 2	<b>Was any of this waste managed on-site?</b> No	
<b>ON-SITE PROCESS SYSTEM 1</b> On-site process system type		<b>ON-SITE PROCESS SYSTEM 2</b> On-site process system type
Quantity treated, disposed, or recycled on-site in 2003		Quantity treated, disposed, or recycled on-site in 2003

Sec. 3	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b> 1	<b>B. EPA ID No. of facility to which waste was shipped</b> NMD002208627	<b>C. Off-site Management Method code shipped to</b> H141	<b>D. Total quantity shipped in 2003</b> 0.04

**Comments** CHEMICALS DISPOSED AS PART OF THE DECOMMISSIONING OF THE PLANT. THE MANUFACTURING PROCESS STOPPED IN OCTOBER OF 2003.  
NULL.



SITE NAME  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
EPA ID NO: NMD000709782



WASTE GENERATION AND MANAGEMENT

Sec. 1	<b>A. Waste Description</b> FLOWABLE OXIDE (FOX), AN IGNITABLE SOLVENT USED IN THE MANUFACTURE OF SEMICONDUCTOR DEVICES. PRIMARILY CONTAINS ORGANIC SOLVENTS.		
<b>B. EPA Hazardous Waste Code</b> D001 D003		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G15  <b>Management Method code for Source code G25</b>	<b>E. Form Code</b>  W210	<b>F. Quantity Generated in 2003</b>  0.13	<b>G. UOM</b> 2  <b>Density</b> 1.00 spec.gra

Sec. 2	<b>Was any of this waste managed on-site?</b> NO	
<b>ON-SITE PROCESS SYSTEM 1</b> On-site process system type		<b>ON-SITE PROCESS SYSTEM 2</b> On-site process system type
Quantity treated, disposed, or recycled on-site in 2003		Quantity treated, disposed, or recycled on-site in 2003

Sec. 3	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b> 1	<b>B. EPA ID No. of facility to which waste was shipped</b> NMD002208627	<b>C. Off-site Management Method code shipped to</b> H141	<b>D. Total quantity shipped in 2003</b> 0.13

**Comments** CHEMICALS DISPOSED AS PART OF THE DECOMMISSIONING PROCESS. THE MANUFACTURING PROCESS STOPPED IN OCTOBER OF 2003.

NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

**FORM GM**

**WASTE GENERATION AND MANAGEMENT**

<b>Sec. 1</b>	<b>A. Waste Description</b> SOLVENT CONTAMINATED METAL DUCT WORK. CONTAINS SMALL AMOUNTS OF ACETONE, ISOPROPANOL, PROPANOL ACETATE.		
<b>B. EPA Hazardous Waste Code</b> D001 F003		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G15 Management Method code for Source code G25	<b>E. Form Code</b> W002	<b>F. Quantity Generated in 2003</b> 0.14	<b>G. UOM 2</b> Density 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> No	
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b> <b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b> 1	<b>B. EPA ID No. of facility to which waste was shipped</b> AZD081705402	<b>C. Off-site Management Method code shipped to</b> H141	<b>D. Total quantity shipped in 2003</b> 0.14

**Comments**  
NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**SITE NAME**  
 PHILIPS SEMICONDUCTORS  
 9201 PAN AMERICAN FRWY. NE  
 ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

**FORM GM**

**WASTE GENERATION AND MANAGEMENT**

<b>Sec. 1</b>	<b>A. Waste Description</b> MIXED INORGANIC ACIDS FOR USE IN THE MANUFACTURE OF SEMICONDUCTOR DEVICES. INCLUDES PHOSPHORIC, HYDROCHLORIC, AND HYDROFLUORIC ACIDS.		
<b>B. EPA Hazardous Waste Code</b> D002		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G15 Management Method code for Source code G25	<b>E. Form Code</b> W103	<b>F. Quantity Generated in 2003</b> 9.39	<b>G. UOM</b> 2 Density 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> No	
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b> <b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b> 1	<b>B. EPA ID No. of facility to which waste was shipped</b> NMD002208627	<b>C. Off-site Management Method code shipped to</b> H141	<b>D. Total quantity shipped in 2003</b> 9.39

**Comments** CHEMICALS DISPOSED AS PART OF DECOMMISSIONING THE PLANT. THE MANUFACTURING PROCESS STOPPED IN OCTOBER OF 2003.  
 .NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**WASTE GENERATION AND MANAGEMENT**

**FORM GM**

**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

<b>Sec. 1</b>	<b>A. Waste Description</b> AMMONIUM HYDROXIDE USED IN THE MANUFACTURE OF SEMICONDUCTOR DEVICES.		
<b>B. EPA Hazardous Waste Code</b> D002		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G15 Management Method code for Source code G25	<b>E. Form Code</b> W110	<b>F. Quantity Generated in 2003</b> 0.31	<b>G. UOM</b> 2 Density 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> NO	
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b> <b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b> 1	<b>B. EPA ID No. of facility to which waste was shipped</b> NMD002208627	<b>C. Off-site Management Method code shipped to</b> H141	<b>D. Total quantity shipped in 2003</b> 0.31

**Comments** CHEMICALS DISPOSED AS PART OF THE DECOMMISSIONING OF THE PLANT. THE MANUFACTURING PROCESS STOPPED IN OCTOBER OF 2003.  
NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**WASTE GENERATION AND MANAGEMENT**



**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

<b>Sec. 1</b>	<b>A. Waste Description</b> CONTAMINATED DEBRIS.		
<b>B. EPA Hazardous Waste Code</b> D002 D004 D008		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G15 <b>Management Method code for Source code G25</b>	<b>E. Form Code</b> W002	<b>F. Quantity Generated in 2003</b> 3.26	<b>G. UOM</b> 2 <b>Density</b> 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> No		
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>	
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b> 1	<b>B. EPA ID No. of facility to which waste was shipped</b> NMD002208627	<b>C. Off-site Management Method code shipped to</b> H141	<b>D. Total quantity shipped in 2003</b> 3.26

**Comments** CONTAMINATED EQUIPMENT DISPOSED OF AS PART OF THE DECOMMISSIONING OF THE PLANT. THE MANUFACTURING PROCESS STOPPED IN OCTOBER OF 2003.  
NULL.



U.S. ENVIRONMENTAL PROTECTION AGENCY  
2003 Hazardous Waste Report

**WASTE GENERATION AND MANAGEMENT**

**FORM GM**

**SITE NAME**  
 PHILIPS SEMICONDUCTORS  
 9201 PAN AMERICAN FRWY. NE  
 ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

<b>Sec. 1</b>	<b>A. Waste Description</b> WASTE WATER WITH CHROME.		
<b>B. EPA Hazardous Waste Code</b> D007		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G15 Management Method code for Source code G25	<b>E. Form Code</b> W101	<b>F. Quantity Generated in 2003</b> 0.14	<b>G. UOM</b> 2 Density 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> NO	
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b> <b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b> 1	<b>B. EPA ID No. of facility to which waste was shipped</b> NMD002208627	<b>C. Off-site Management Method code shipped to</b> H141	<b>D. Total quantity shipped in 2003</b> 0.14

**Comments** WASTES FROM DECOMMISSIONING OF THE PLANT. MANUFACTURING PROCESS STOPPED IN OCTOBER OF 2003.  
 .NULL.



**WASTE GENERATION AND MANAGEMENT**



SITE NAME  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
EPA ID NO: NMD000709782

Sec. 1	A. Waste Description WASTE PAINT MATERIALS.		
B. EPA Hazardous Waste Code D001		C. State Hazardous Waste Code	
D. Source Code G06 Management Method code for Source code G25	E. Form Code W209	F. Quantity Generated in 2003 0.78	G. UOM 2 Density 1.00 spec.gra

Sec. 2	Was any of this waste managed on-site? No		
ON-SITE PROCESS SYSTEM 1		ON-SITE PROCESS SYSTEM 2	
On-site process system type	Quantity treated, disposed, or recycled on-site in 2003	On-site process system type	Quantity treated, disposed, or recycled on-site in 2003

Sec. 3	A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling? Yes		
Site #	B. EPA ID No. of facility to which waste was shipped	C. Off-site Management Method code shipped to	D. Total quantity shipped in 2003
1	NMD002208627	H141	0.31
2	IND093219012	H061	0.24
3	AZD081705402	H061	0.22

Comments  
  
NULL



U.S. ENVIRONMENTAL  
PROTECTION AGENCY  
2003 Hazardous Waste Report

**WASTE GENERATION  
AND MANAGEMENT**

**FORM  
GM**

**SITE NAME**  
PHILIPS SEMICONDUCTORS  
9201 PAN AMERICAN FRWY. NE  
ALBUQUERQUE, NM 87113  
**EPA ID NO:** NMD000709782

<b>Sec. 1</b>	<b>A. Waste Description</b> DEBRIS CONTAMINATED WITH LEAD.		
<b>B. EPA Hazardous Waste Code</b> D008		<b>C. State Hazardous Waste Code</b>	
<b>D. Source Code</b> G15 <b>Management Method code for Source code G25</b>	<b>E. Form Code</b> W002	<b>F. Quantity Generated in 2003</b> 0.12	<b>G. UOM</b> 2 <b>Density</b> 1.00 spec.gra

<b>Sec. 2</b>	<b>Was any of this waste managed on-site?</b> No	
<b>ON-SITE PROCESS SYSTEM 1</b>		<b>ON-SITE PROCESS SYSTEM 2</b>
<b>On-site process system type</b>	<b>Quantity treated, disposed, or recycled on-site in 2003</b>	<b>On-site process system type</b> <b>Quantity treated, disposed, or recycled on-site in 2003</b>

<b>Sec. 3</b>	<b>A. Was any of this waste shipped off site in 2003 for treatment, disposal, or recycling?</b> Yes		
<b>Site #</b> 1	<b>B. EPA ID No. of facility to which waste was shipped</b> NMD002208627	<b>C. Off-site Management Method code shipped to</b> H141	<b>D. Total quantity shipped in 2003</b> 0.12

**Comments** WASTE GENERATED FROM DECOMMISSIONING OF THE PLANT. MANUFACTURING STOPPING IN OCTOBER 2003.  
  
NULL.



**FORM  
OI**

**OFF-SITE  
IDENTIFICATION**

SITE NAME PHILIPS SEMICONDUCTORS PAN AMERICAN FRWY. NE ALBUQUERQUE		NM 87113
EPA ID NO: <b>NMD000709782</b>		

A. EPA ID No. of off-site installation or transporter ARD069748192	B. Name of off-site installation or transporter ENSCO INC
C. Handler Type  <input type="checkbox"/> Generator <input type="checkbox"/> Transporter <input checked="" type="checkbox"/> TSDR	D. Address of off-site installation Street 309 AMERICAN CIRCLE  City EL DORADO State AR Zip 71730-

A. EPA ID No. of off-site installation or transporter AZD081705402	B. Name of off-site installation or transporter HERITAGE ENVIRONMENTAL SERVICES
C. Handler Type  <input type="checkbox"/> Generator <input type="checkbox"/> Transporter <input checked="" type="checkbox"/> TSDR	D. Address of off-site installation Street 5122 EAST STOREY ROAD  City COOLIDGE State AZ Zip 85228-

A. EPA ID No. of off-site installation or transporter IND093219012	B. Name of off-site installation or transporter HERITAGE ENVIRONMENTAL SERVICES
C. Handler Type  <input type="checkbox"/> Generator <input type="checkbox"/> Transporter <input checked="" type="checkbox"/> TSDR	D. Address of off-site installation Street 7901 WEST MORRIS STREET  City INDIANAPOLIS State IN Zip 46231-

A. EPA ID No. of off-site installation or transporter KSD980633259	B. Name of off-site installation or transporter SYSTECH ENVIRONMENTAL CORP
C. Handler Type  <input type="checkbox"/> Generator <input type="checkbox"/> Transporter <input checked="" type="checkbox"/> TSDR	D. Address of off-site installation Street 1420 SOUTH CEMENT ROAD  City FREDONIA State KS Zip 66736-

A. EPA ID No. of off-site installation or transporter ILD006493191	B. Name of off-site installation or transporter SCHIBER TRUCK COMPANY
C. Handler Type  <input type="checkbox"/> Generator <input checked="" type="checkbox"/> Transporter <input type="checkbox"/> TSDR	D. Address of off-site installation Street P.O. 68  City HARLAND State IL Zip 62408-



**OFF-SITE IDENTIFICATION**

**SITE NAME**  
PHILIPS SEMICONDUCTORS  
PAN AMERICAN FRWY. NE  
ALBUQUERQUE NM 87113  
  
EPA ID NO: **NMD000709782**

<b>A. EPA ID No. of off-site installation or transporter</b> UTD981552425	<b>B. Name of off-site installation or transporter</b> SLT EXPRESS
<b>C. Handler Type</b>  N Generator Y Transporter N TSDR	<b>D. Address of off-site installation</b> Street 176 WEST CENTRAL AVE  City MURRY State UT Zip 8407 -

<b>A. EPA ID No. of off-site installation or transporter</b> NMD002208627	<b>B. Name of off-site installation or transporter</b> RINCHEM COMPANY
<b>C. Handler Type</b>  N Generator Y Transporter Y TSDR	<b>D. Address of off-site installation</b> Street 6133 EDITH BLVD. NE  City ALBUQUERQUE State NM Zip 87107 -

<b>A. EPA ID No. of off-site installation or transporter</b> OKD981588791	<b>B. Name of off-site installation or transporter</b> TRIAD TRANSPORT
<b>C. Handler Type</b>  N Generator Y Transporter N TSDR	<b>D. Address of off-site installation</b> Street 1630 E. ELECTRIC  City MCALESTER State OK Zip 7450-1

<b>A. EPA ID No. of off-site installation or transporter</b> IND058484114	<b>B. Name of off-site installation or transporter</b> HERITAGE TRANSPORT LLC
<b>C. Handler Type</b>  N Generator Y Transporter N TSDR	<b>D. Address of off-site installation</b> Street 7901 WEST MORRIS STREET  City INDIANAPOLIS State IN Zip 46231 -